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SERIAL NUMBER 10/802,886	FILING OR 371(c) DATE 03/18/2004 RULE	CLASS 430	GROUP ART UNIT 1756	ATTORNEY DOCKET NO. Q80568
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## APPLICANTS

Tsutomu Shoki, Tokyo, JAPAN;

\*\* CONTINUATING DATA \*\*\*\*\*

*NONE*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 74897/2003 03/19/2003

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/31/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no		
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i> Initials		
STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS

## ADDRESS

23373

## TITLE

Method of producing a reflective mask and method of producing a semiconductor device

FILING FEE RECEIVED 856	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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